

# Metrology for the Factory of the Future

Mathematical Modelling and Algorithms for the Aggregation of data from

**Industrial Sensor Networks** 



<u>Yuhui Luo</u>	<u>Gertjan Kok</u>	<u>Loïc Coquelin</u>
Data Science Dept NPL	Applied Mathematics VSL	Département Science des Données et Incertitude LNE
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- Industrial Trends & Challenges
- Network Synchronisation and Timing
- Redundant Measurement
- Feature Selection with Mixed Quality Sensors

### Acknowledgement



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- As a presenter of their work, my thanks go to Kavya Jagan, Liam Wright and Peter Harris of NPL and Bang Xiang Yong of University of Cambridge for their supports.

### Background

#### **Current Industrial Trend**

- Large amount of sensors become available
- Increased computational capacity
- The wider applications of ML algorithm
- Concerns of confidence of sensor data and algorithm output

#### A few challenges in metrology for the Factory of Future

- Data aggregation & Data cleaning
- Data Fusion
- Network synchronisation and timing
- Redundant measurements
- Network design for mixed quality sensors
- Multiagent system



### **Network Synchronisation and Timing**



### Our aim was to formulate and answer the following questions:

- For the measured data, how to model the data in the presence of synchronisation effects and jitter?
- How to estimate the model parameters?
- How to evaluate the uncertainty of the result?



### Data model for synchronisation effects and jitter

Model for measured signal

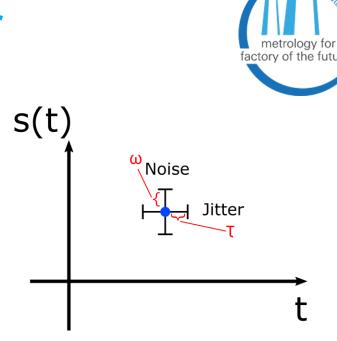
- -s(t): true data
- $\eta$  : measurement error with variance  $\omega^2$
- $\xi$  : timing error with variance  $\tau^2$
- $\eta$  and  $\xi$  are assumed to be samples drawn independently from Gaussian distributions that are independent of time and of the signal and of each other.

 $v(t) = s(t + \xi) + \eta$ 

Under some (mild) assumptions

$$E[v(t)] \approx s(t) + \frac{1}{2}(\tau^2)s^{(2)}(t)$$
$$V[v(t)] \approx (\tau^2)\{s^{(1)}(t)\}^2 + \omega^2$$







### Data model for sychronisation noise and jitter - Continued

- Since the underlying data is unknown, cubic polynomial  $\psi(t; a)$  is used to approximate the underlying data in a short window, where a are the parameters of the cubic polynomial function.
- The parameters to be estimated: *a* (parameter of cubic polynomial),  $\omega^2$  (variance of noise) and  $\tau^2$  (variance of jitter)
- In some circumstances, repeated measurements of the signal can be used to estimate noise and jitter variances.
- However, in several measurement scenarios, repeated measurements are not recorded or not possible and the noise and jitter variances need to be estimated on the basis of the available data.





### **Parameter Estimation**

Use Bayesian approach, likelihood function:

$$h(\boldsymbol{v}|\boldsymbol{a},\tau^{2},\omega^{2}) \propto \prod_{j=1}^{N} \frac{1}{\sqrt{\tau^{2}\psi^{(1)}(t_{j},\boldsymbol{a})^{2}+\omega^{2}}} \exp\left\{-\frac{(v_{j}-\psi(t_{j};\boldsymbol{a})-0.5\,\tau^{2}\psi^{(2)}(t_{j};\boldsymbol{a}))^{2}}{2(\tau^{2}\{\psi^{(1)}(t_{j};\boldsymbol{a})\}^{2}+\omega^{2})}\right\}$$

-  $\psi^{(1)}(\bullet)$  and  $\psi^{(2)}(\bullet)$  are the first and second derivatives of the cubic polynomial

By Bayes' theorem, the posterior distribution is given by

 $g(\boldsymbol{a},\tau^2,\omega^2|\boldsymbol{v}) \propto h(\boldsymbol{v}|\boldsymbol{a},\tau^2,\omega^2)g(\boldsymbol{a})g(\tau^2)g(\omega^2)$ 



### **Uncertainty of the Result from Parameter Estimation**

Selection of the prior used to determine the in the posterior distribution

 $g(\boldsymbol{a}, \tau^2, \omega^2 | \boldsymbol{v}) \propto h(\boldsymbol{v} | \boldsymbol{a}, \tau^2, \omega^2) g(\boldsymbol{a}) g(\tau^2) g(\omega^2)$ 

where  $g(a) \propto 1$  - non-informative prior  $g(\omega^2), g(\tau^2) \propto (\tau^2)^{-(\alpha+1)} \exp \frac{-\beta}{\tau^2}$  - inverse gamma distribution prior

- Generation of the posterior distribution Metropolis-Hastings algorithm
- See: Jagan, K., Wright, L. and Harris, P., A Bayesian approach to account for timing effects in industrial sensor networks, 2020 IEEE International Workshop on Metrology for Industry 4.0 IoT

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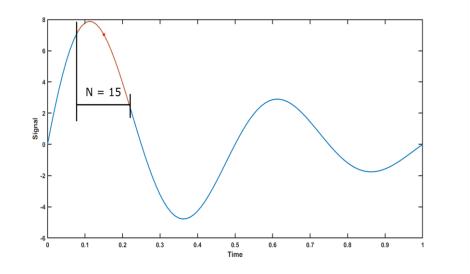
### **Numerical Example**

Using the simulated signal

 $s(t) = a e^{-bt} \sin(2\pi f t), \qquad 0 \le t \le 1$ 

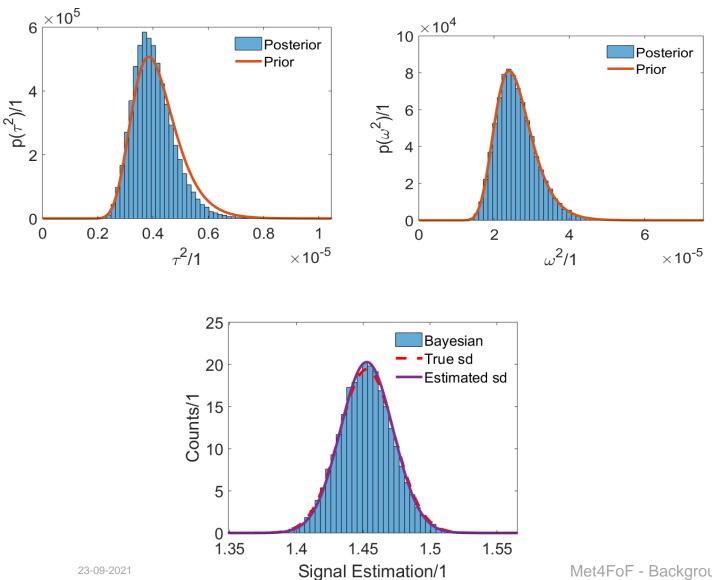
• Where a = 10, b = 2 and f = 2. Signal is sampled with uniform spacing of 0.01s. Jitter and noise levels are set as  $\tau = 0.002$  and  $\omega = 0.005$  respectively.







## **Numerical Example - Continued**



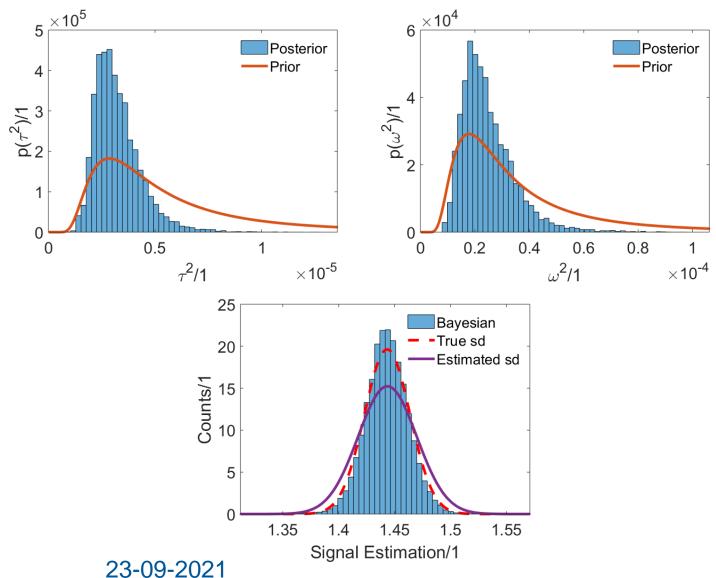


- This is the result of using well informed priori.
- It produces posteriors that are very similar to the prior distribution
- Good agreement between the distributions of the signal estimate for mid-point of window



### **Numerical Example - Continued**





- Less informed prior and simulated data produce less dispersed posteriors that the priors.
- Surprisingly good agreement between the distributions of the signal estimate for mid-point of window.
- Software will be available in Met4FoF Github repository.



### **VSL** Redundant measurement

#### Our aim was to formulate and answer the following questions:

- What is redundancy exactly? How can you quantify it?
- How can you take advantage of redundancy?
- How can these ideas be applied to the three testbeds?
- Which non-testbed specific software tools can we make freely available?



### VSL What is redundancy in a metrological sensor network?

- "The property that there are multiple, independent ways of deriving the value of the measurand from the set of measured sensor values, quantified by a notion of gradual uncertainty increase when sensors fail / are removed."
- Related concepts:
  - sensor replication: can the data of one sensor be replicated by (a group of) other sensors?
  - sensor relevance: how relevant is a sensor for knowing the measurand value?
- Most useful metrological redundancy metrics:
  - Red-Excess: Calculate the number of sensors present in the network in excess of the minimum number necessary to determine the values of the measurand
  - Red-Unc-*m*: Maximum increase in uncertainty of measurand Y when taking out *m* relevant sensors
- See: Kok, G. and Harris, P. Quantifying Metrological Redundancy in an Industry 4.0 Environment, 2020 IEEE International Workshop on Metrology for Industry 4.0 IoT

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Met4FoF - Background

### VSL How can one take advantage of redundancy?

- Sanity check of network based on measured values, e.g.:
  - Check if synchronized events
  - Check algebraïc and integral equations
- Identify and reject faulty measurement values
- Reduce measurement uncertainty
  - Using classical tools also used for analyzing intercomparison data
  - Extended to case: y = a + A x, i.e. possibility to reject individual sensor values  $x_i$  instead of estimates  $y_j$  of the measurand only. 'Largest Consistent Subset of Sensors (LCSS) algorithm'
- Interpolation and calibration of uncalibrated sensors
  - Study of various mathematical models (e.g. Gaussian Processes) for distributed measurement in SPEA testbed. What is the best model, what is the uncertainty?
- See: Kok, G. and Harris, P. Uncertainty Evaluation for Metrologically Redundant Industrial Sensor Networks, 2020 IEEE International Workshop on Metrology for Industry 4.0 IoT

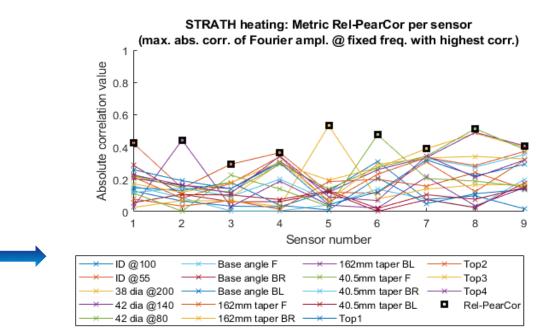
 $u(\hat{y}) = \left(\mathbf{e}^{\mathrm{T}}V_{\mathbf{y}}^{-1}\mathbf{e}\right)^{-1/2}$  $\hat{y} = u^{2}(\hat{y}) \mathbf{e}^{\mathrm{T}}V_{\mathbf{y}}^{-1}\mathbf{y}$ 



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### **VSL** Application to testbeds

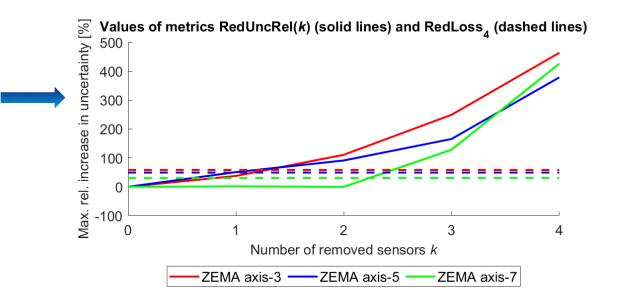
- STRATH:
  - Sanity checks, e.g. comparing integrated speed with position
  - Redundancy metrics: Assess relevance of each sensor for measurand based on Pearson correlation value of selected data feature





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- Redundancy metrics, e.g. Red-Unc-*m* metric: Uncertainty increase when taking out sensors (model dependent)
- Combing residual life time estimates based on calculated uncertainties
- Application of LCSS algorithm to remove erroneous sensor values. (No improvement in prediction quality...)





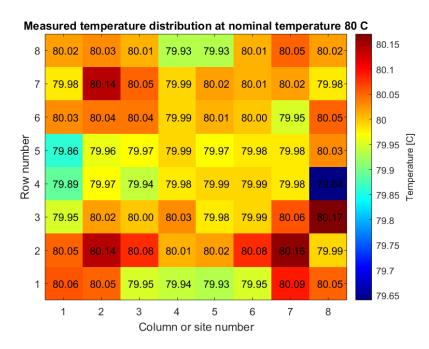
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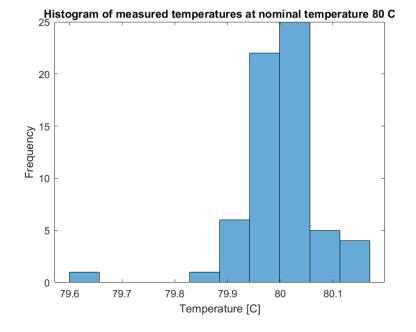
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### VSL Application to testbeds (2)

- SPEA:
  - Identify strange values
  - Interpolate between reference sensors
  - Nearest Neighbour model with additional uncertainty seems more appropriate than Gaussian Process with significant correlation structure
- Some general software tools integrated in AgentMet4FoF framework and separate, non-agent versions (LCSS)
- Software available in Met4FoF Github repository: https://github.com/Met4FoF/Met4FoF-redundancy
- Documentation available in ReadTheDocs: https://met4fofredundancy.readthedocs.io/en/master/





### Network design for mixed quality sensors



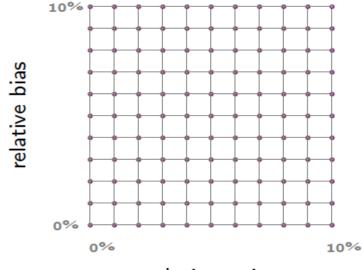
#### Our aim was to formulate and answer to following questions:

- How to design an experiment to model the influence of mixed quality sensors?
- Taking into account the quality issue of sensors, how to select the relevant sensor and the relevant features from a big pool?
- What happen if uncertainties related to features are concerned ?



### **Design of Experiment and Data Model**

- The mixed quality sensors are modelled as data with different levels of additive noise.
- Evaluation on a 2D cartesian Grid
  - relative bias : 0% to 10% of the mean
  - additive noise : 0% to 10% of the mean
  - 100 classification accuracy evaluations



relative noise





 $\triangleright$  X<sub>i</sub>, the input vector storing the *i*-th observation from the whole set of sensors

- $\blacklozenge \phi(X_{i}) \in \mathbb{R}^{d}$ , the d-dimensional feature vector extracted from the input  $X_{i}$
- Modelling

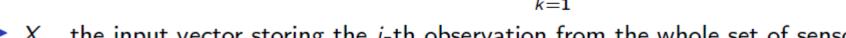
The target  $t_i$  is representative of the true model  $y_i$  with the addition of noise  $\epsilon_i$ 

$$t_i = y_i + \epsilon_i,$$
  

$$t_i = w^T \phi(X_{\cdot i}) + \epsilon_i, \quad \epsilon_i \sim \mathcal{N}(0, \tau^{-1})$$

### **Design of Experiment and Data Model -Continued**

- Notation
  - ▶  $\mathcal{D}$ , the training set such that  $\mathcal{D} = \{(X_{i}, t_i), i = 1, ..., n\}$
  - *n<sub>s</sub>*, the number of sensors
  - $\triangleright$  s<sub>k</sub> feature set of sensor k
  - $\triangleright$   $d_k$ , the number of features extracted from sensor k
  - d, the total number of extracted features,  $d = \sum_{k=1}^{n_s} d_k$





### **Features Selection**



- The algorithms of Relevance Vector Machine (RVM) and its extension Relevant Group Selector (RGS) are applied to select relevant sensors and the relevant features.
- The RVM and RGS algorithms are hierarchical Bayesian formulations that allow to introduce grouping (features from different sensor will correspond to a different group) and to simultaneously perform feature selection within groups to reduce over-fitting of the data.
- Introducing the  $\lambda_{1,j}$  and  $\lambda_{2,k}$  whose inverse are related to the weights of sensors and the features respectively, the RGS algorithm model can be summarized as:

$$p(t|X, w, \tau) = \prod_{i=1}^{n} \mathcal{N}(t_i|w^T \phi(X_{\cdot i}), \tau^{-1})$$
$$p(w|\lambda_1, \lambda_2) = \prod_{k=1}^{n_s} \prod_{j \in s_k} \mathcal{N}\left(w_j|0, (\lambda_{1,j} + \lambda_{2,k})^{-1}\right)$$



### **Features Selection - Continued**

• Further sparse feature selection is proposed by either weight thresholding or elbow method

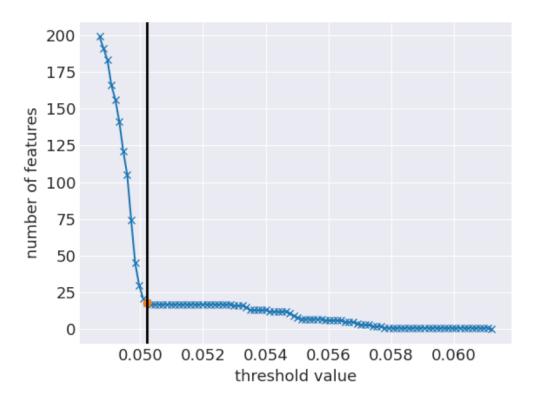


illustration of the elbow method to find the optimal number of features to select





### **When Uncertainty of Feature Included**

 $\Phi_{ii} \sim \mathcal{N}_d \left( \phi(X_{ii}), \sigma^2 I_d \right)$ 

Homogeneous Uncertainty – features have same variance in uncertainty

$$p(t|X, w, \tau) = \prod_{i=1}^{n} \mathcal{N}(t_i|w^T \Phi_{\cdot i}, \tau^{-1})$$

$$p(w|\lambda_1, \lambda_2) = \prod_{k=1}^{n_s} \prod_{i \in s_k} \mathcal{N}\left(w_j|0, \sigma_{\phi}^2 + (\lambda_{1,j} + \lambda_{2,k})^{-1}\right)$$

Heterogeneous uncertainty case – different features has difference variance in uncertainty

$$\begin{split} \Phi_{\cdot i} &\sim \mathcal{N}_d \left( \phi(X_{\cdot i}), \Sigma_\phi \right) \\ p(t|X, w, \tau) &= \prod_{i=1}^n \mathcal{N}(t_i | w^T \Phi_{\cdot i}, \tau^{-1}) \\ p(w|\lambda_1, \lambda_2) &= \prod_{k=1}^{n_s} \prod_{j \in s_k} \mathcal{N} \left( w_j | 0, \sigma_{\phi_j}^2 + (\lambda_{1,j} + \lambda_{2,k})^{-1} \right) \end{split}$$

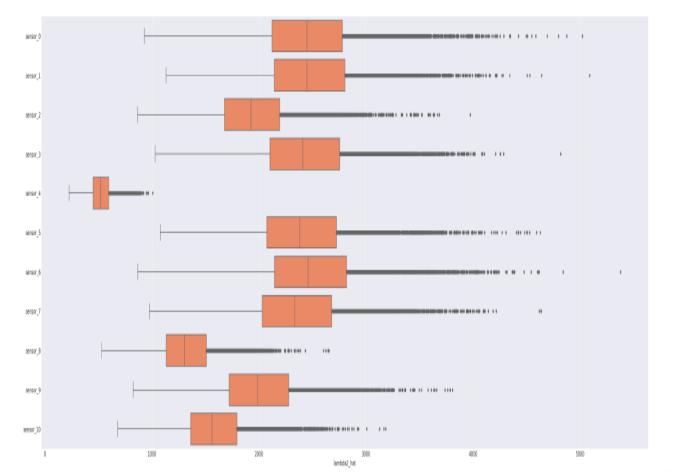




### **ZeMA Result**

- sensor 0: microphone
- sensor 1: acceleration plain bearing
- sensor 2: acceleration piston rod
- sensor 3: acceleration ball bearing
- sensor 4: axial force
- sensor 5: pressure
- sensor 6: velocity
- sensor 7: active current
- sensor 8: motor current phase 1
- sensor 9: motor current phase 2
- sensor 10: motor current phase 3
- sensor  $4 \longrightarrow \text{most relevant sensor}$
- sensor 8
- sensor 10
- sensor 2, 9
- sensor 0, 1, 3, 5, 6, 7  $\longrightarrow$  irrelevant sensors











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